

Application Data Sheet

Application Information

Application Type:: Regular
Subject Matter:: Utility
Suggested classification::
Suggested Group Art Unit::
CD-ROM or CD-R?:: None
Computer Readable Form (CRF)?:: No
Title:: PROCESS FOR LINING A SURFACE
USING AN ORGANIC FILM
Attorney Docket Number:: 355901-0110
Request for Early Publication?:: No
Request for Non-Publication?:: No
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 6
Small Entity?:: No
Petition included?:: No
Secrecy Order in Parent Appl.?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: France
Status:: Full Capacity
Given Name:: Christophe
Family Name:: Bureau
City of Residence:: Suresnes

Country of Residence:: France
Street of mailing address:: 24, rue de la liberté
Suresnes
France F-92150

Country of mailing address:: France

Applicant Authority Type:: Inventor

Primary Citizenship Country:: France

Status:: Full Capacity

Given Name:: Guy

Family Name:: Deniau

City of Residence:: Auffargis

Country of Residence:: France

Street of mailing address:: 5, allée de la ferme

Auffarg

France F-78610

Country of mailing address:: France

Applicant Authority Type:: Inventor

Primary Citizenship Country:: France

Status:: Full Capacity

Given Name:: Serge

Family Name:: Palacin

City of Residence:: Montigny le Bretonneux

Country of Residence:: France

Street of mailing address:: 21, rue Antoine Coypel

Montigny le Bretonneux

France F-78180

Country of mailing address:: France

Correspondence Information

Correspondence Customer Number:: 38706

E-Mail address:: PTOMailSiliconValley@foley.com

Representative Information

Representative Customer Number::	38706	
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/FR2003/50035	8/25/2003

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
France	FR 02 10568	8/26/2002	Yes

Assignee Information

Assignee Name:: Commissariat a L'Energie Atomique